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In re the Application of: MATSUZAWA, Minoru, et al. Attention: Applications Division

Serial Number: 10/516,949 Group Art Unit: 1762

Filed: December 16, 2004 P.T.O. Confirmation No.: 4976

For: SUBSTRATE TREATMENT APPARATUS AND SUBSTRATE TREATMENT METHOD

### REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: March 14, 2006 Sir:

Please supply the undersigned attorney with a corrected filing receipt for the above-identified application. The undersigned also respectfully requests that the Patent and Trademark Office records be amended to reflect the correction.

In reviewing the official Filing Receipt, we noted an error in that the title is incorrect and should read as --SUBSTRATE TREATMENT APPARATUS AND SUBSTRATE TREATMENT METHOD--. A copy of the Declaration is enclosed which indicates the correct information. We are enclosing a copy of the filing receipt with the corrections highlighted.

In the event that any fees are required in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP/

Donald W. Hapson Attorney for Applicants Reg. No. 27,133

genelle

DWH/bjb Atty. Docket No. **040667** Suite 1000 1725 K Street, N.W. Washington, D.C. 20006 (202) 659-2930

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Enclosures: Official Filing Receipt and Declaration



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**CONFIRMATION NO. 4976** 

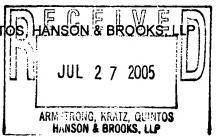
**FILING RECEIPT** 

\*OC000000016596433\*

Date Mailed: 07/25/2005

23850 ARMSTRONG, KRATZ, QUINTIOS 1725 K STREET, NW **SUITE 1000** 

WASHINGTON, DC 20006



Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Minoru Matsuzawa, Tokyo, JAPAN; Michio Nagasaka, Tokyo, JAPAN;

Power of Attorney: The patent practitioners associated with Customer Number 23850.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/07849 06/20/2003

Foreign Applications

JAPAN 2002-181151 06/21/2002

Projected Publication Date: 11/03/2005

Non-Publication Request: No

Early Publication Request: No

\*\* SMALL ENTITY \*\*

Title

Substrate processing device and substrate processing method SUBSTRATE TREATMENT APPARATUS AND SUBSTRATE TREATMENT METHOD



Docket No.

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, I.L.P

## **Declaration and Power of Attorney for Patent Application**

特許出願宣言書及び委任状

Japanese Language Declaration 日本語宣言書

私は、以下に記名された発明者として、ここに下記の通り宣言する:	As a below named inventor, I hereby declare that:		
私の住所、郵便の宛先そして国籍は、私の氏名の後に記載された通りである。	. My residence, post office address and citizenship are as stated next to my name.		
下記の名称の発明について、特許請求範囲に記載され、且つ特許が 求められている発明主題に関して、私は、最初で、最先且つ唯一の 発明者である(唯一の氏名が記載されている場合)か、或いは最 初、最先且つ共同発明者である(複数の氏名が記載されている場 合)と信じている。	I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled		
	SUBSTRATE TREATMENT APPARATUS AND		
	SUBSTRATE TREATMENT METHOD		
	the specification of which is attached hereto unless the following box is checked:		
上記発明の明細書はここに添付されているが、下記の欄がチェックされている場合は、この限りでない:	·		
	was filed on June 20, 2003		
□の日に出願され、 この出願の米国出願番号または PCT 国際出願番号は、 であり、且つ . の日に補正された出願(該当する場合)	as United States Application Number or PCT International Application Number PCT/JP03/07849 and was amended on (if applicable).		
私は、上記の補正書によって補正された、特許請求範囲を含む上記 明細書を検討し、且つ内容を理解していることをここに表明する。	I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.		
労和哲を使削し、且 プロ社を生がしていることをここに表別する。			
私は、連邦規則法典第37編規則1.56に定義されている、特許 性について重要な情報を開示する義務があることを承認する。	I acknowledge the duty to disclose information which is material to patentability as defined in Title 37, Code of Federal Regulations, Section 1.56.		

Docket No. \_\_\_

### Declaration and Power of Attorney for Patent Application

特許出願宣言書及び委任状

#### Japanese Language Declaration 日本語宣言書

私は、ここに、以下に記載した外国での特許出願または発明者証出 願、或いは米国以外の少なくとも一国を指定している米国法典第35編 第365条(a)によるPCT国際出願について、同第119条(a)(b)項 又は第365条(b)項に基づいて優先権の利益を主張するとともに、優 先権を主張する本出願の出願日よりも前の出願日を有する外国で特許出 願または発明者証出願、或いはPCT国際出願については、いかなる出 願も、下記の枠内をチェックすることにより示した。

I hereby claim foreign priority benefits under Title 35, United States Code, Section 119(a)-(d) or 365(b) of any foreign application(s) for patent or inventor's certificate, or 365(a) of any PCT International application which designated at least one country other than the United States listed below and have also identified below, by checking the box, any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application for which priority is claimed.

Prior Foreign Application(s) 外国での先行出願		
2002-181151 (Number) (番号)	Japan (Country) (国名)	
(Number) (番号)	(Country) (国名)	
他の優先権出願については	添付のリスト参照	
私は、ここに、下記のいか	なる米国仮特許出願についても	、その米

К 国法典第35編119条(e)項の利益を主張する。

(Application No.) (出願番号)

(Filing Date) (出願日)

私は、ここに、下記のいかなる米国出願についても、その米国法典第 35編第120条に基づく利益を主張し、又米国を指定するいかなる PCT国際出願についても、その同第365条(c)に基づく利益を主 張する。また、本出願の各特許請求の範囲の主題が、米国法典第35 編第112条第1段に規定された態様で、先行する米国出願又はPC T国際出願に開示されていない場合においては、その先行出願の出願 日と本国内出願日またはPCT国際出願日との間の期間中に入手され た情報で、連邦規則法典第37編規則1.56に定義された特許性に 関る重要な情報について開示義務があることを承認する。

(Application No.) (出願番号)

(Filing Date) (出願日)

(Application No.)

(Filing Date) (出願日)

私は、ここに表明された私自身の知識に係わる陳述が真実であり、 且つ情報と信ずることに基づく陳述が、真実であると信じられることを宣言し、さらに、故意に虚偽の陳述などを行った場合は、米国法典 第18編第1001条に基づき、罰金または拘禁、若しくはその両方 により処罰され、またそのような故意による虚偽の陳述は、本出願ま たはそれに対して発行されるいかなる特許も、その有効性に問題が生 ずることを理解した上で陳述が行われたことを、ここに宣言する。

Priority YES NO Claimed 優先権主張 あり なし June 21, 2002  $\boxtimes$ (Day/Month/Year Filed) (出願日/月/年)  $\Box$ (Day/Month/Year Filed) (出願日/月/年) See attached list for additional prior foreign applications. I hereby claim the benefit under Title 35, United States Code, Section 119(e) of any United States provisional application(s) listed below. (Application No.) (Filing Date)

I hereby claim the benefit under Title 35, United States Code, Section 120 of any United States application(s), or 365(c) of any PCT International application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States or PCT International application in the manner provided by the first paragraph of Title 35, United States Code Section 112, I acknowledge the duty to disclose information which is material to patentability as defined in Title 37, Code of Federal Regulations, Section 1.56 which became available between the filing date of the prior application and the national or PCT International filing date of application.

(出願日)

(Status: Patented, Pending, Abandoned) (現況 : 特許許可、係属中、放棄)

(出願番号)

(Status: Patented, Pending, Abandoned) (現況: 特許許可、係属中、放棄)

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under 18 U.S.C. 1001 and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

# **Declaration and Power of Attorney for Patent Application**

特許出願宣言書及び委任状

Japanese Language Declaration 日本語宣言書

日本 四旦 百音 委任状: 私は本出願を審査する手続きを行い、且つ米国特許商標庁 POWER OF ATTORNEY; As a named inventor, I hereby ap との全ての業務を遂行するために、記名された発明者として、下記の弁 護士及び/または弁理士を任命する。 The following attorney(s) and/or agent(s) to prosecute this Application and transact all business in the Patent and Tra

POWER OF ATTORNEY; As a named inventor, I hereby appoint Application and transact all business in the Patent and Trademark Office connected therewith.

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PATENT TRADEMARK OFFICE

全ての通信は下記の住所へ送付されたい。

Please direct all communications to the following address:

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PATENT TRADEMARK OFFICE

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为二天间无列省》、"3物台、飞沙风石		Foli hame of third joint inventor, if any	}
発明者の署名	日付	Signature	Date
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国籍		Citizenship	
郵便の宛先		Post Office Address	